

Inventor: Garo J. Derderian et al
Title: Capacitor Fabrication Methods and Capacitor
Constructions
Assignee: Micron Technology, Inc.
Priority Serial No.: 09/652,532
Priority Filing Date: August 31, 2000
Docket No. MI22-1752



SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

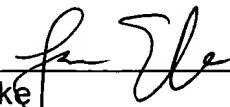
In compliance with 37 C.F.R. §§ 1.56, 1.97 and 1.98, your attention is directed to the United States patents and other references listed on the attached Form PTO-1449. No admission is made regarding whether all the submitted references are prior art.

The listed references were cited by, or submitted to, the Office in the parent, co-pending application of the above-identified application. The above-identified application is a divisional application of co-pending application Serial No. 09/652,532, filed August 31, 2000. Such prior disclosure is sufficient for the above-identified application as far as copies of the references are concerned. 37 C.F.R. § 1.98(d) and MPEP § 609(2).

Citation of these references is respectfully requested.

Respectfully submitted;

Dated: 14 Jun 2001

Attorney: 
James E. Lake
Reg. No. 44,854

EL844046983